



#15/Amend (ONE)  
5.12.03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

C Moore

entered  
7-10-03

J. Liti

APPLICANT: E. I. Broekaart

SERIAL NO.: 09/804,004

EXAMINER: Nathan W. Ha

FILED: March 12, 2001

ART UNIT: 2814

FOR: A METHOD OF MANUFACTURING A SEMICONDUCTOR  
DEVICE

RECEIVED  
MAY - 8 2003  
TECHNOLOGY CENTER 2800

Assistant Commissioner for Patents  
Washington, DC 20231

AMENDMENT UNDER 37 C.F.R. 116

Dear Sir:

In response to the Final Office Action dated March 17, 2003, please amend the  
application as follows:

IN THE CLAIMS:

Kindly add the following claim:

12. (New) The method of claim 1, wherein a capping layer immediately  
adjoins said etch stop layer.

Please do not  
Rush  
6/2/03

C1